

Application Serial No. 10/811,768  
Reply to Office Action of September 23, 2005

OCT 07 2005

PATENT  
Docket: CU-3664

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application: Kiyoshi OOI et al.

Serial No: 10/811,768

Filed: March 29, 2004

For: Semiconductor Device Substrate, Semiconductor Device, and Manufacturing  
Method Thereof

] GRP ART UNIT: 2891

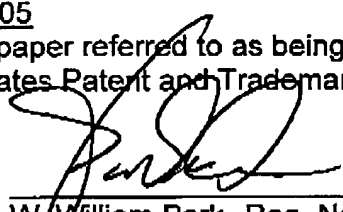
] Ex.: Wilson, Christian D

**Certification under 37 C.F.R. §1.8(a)**

The USPTO Central Fax No. (571) 273-8300

Date of Fax Transmittal: October 7, 2005

I hereby certify that this paper (along with any paper referred to as being attached or  
enclosed) is being transmitted to the United States Patent and Trademark Office to the  
fax number and on the date indicated above.

  
W. William Park, Reg. No. 55,523

The Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO RESTRICTION REQUIREMENT**

In the Office Action dated September 23, 2005, setting a 1-month shortened  
statutory period for a reply ending on October 23, 2005, the pending Claims 1-23 were  
restricted as follows:

Claims 1-9 drawn to a method of making a semiconductor device, classified in  
class 438, subclass 118; and

Claims 10-23 drawn to a semiconductor device, classified in class 257, subclass  
783.

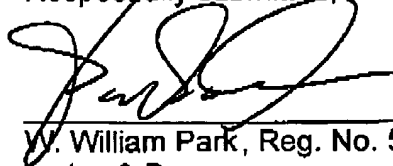
Applicant hereby elects Claims 10-23.

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In view of the Examiner's earlier restriction requirement, Applicants retains the right to present the non-elected in a divisional application.

Respectfully submitted,



Dated: October 7, 2005

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